

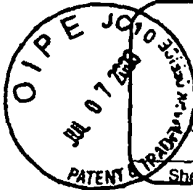
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PTO/SB/08A (04-03)

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Sheet 1 of 12

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| Application Number | 09/808,162 |
| Filing Date | March 13, 2001 |
| First Named Inventor | Yamazaki et al |
| Art Unit | 2812 |
| Examiner Name | V. Simkovic |
| Attorney Docket Number | SEL 139 DIV |

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| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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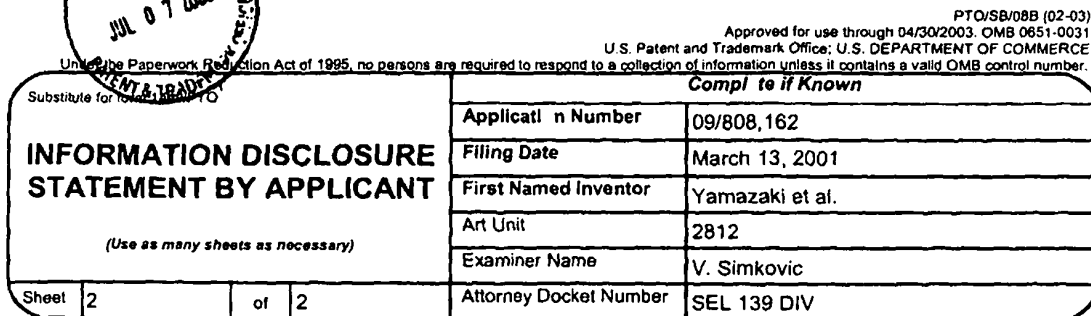
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| Examiner Signature | <i>[Handwritten Signature]</i> | Date Considered | 9/30/03 |
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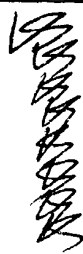


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